

Notice of References Cited

Application/Control No.

10/726,744

Applicant(s)/Patent Under
Reexamination
OLSEN ET AL.

Examiner

Jeffrey T. Barton

Art Unit

1728

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Mattox, D.M. (1998) Handbook of Physical Vapor Deposition (PVD) Processing.. William Andrew Publishing/Noyes. Chapter 6, pages 343-405. Online version available at: http://knovel.com/web/portal/browse/display?_EXT_KNOVEL_DISPLAY_bookid=63&VerticalID=0
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